

Fast component in Xe-doped LAr

ICPPA-2018 22-26.10.2018

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Long

continuous

run

X

X

X

√(***)

X



LAr as a scintillator

- Easy to clean Cheap
- Relatively high density
- Detector scaling possibility
- Two scintillation components Fast (τ_1) 7 ± 1 ns Slow (τ_2) 1600 ± 100 ns
- Pulse shape discrimination (PSD) ability





- One have to use wavelength shifters (WLS)
 - Tetraphenyl butadiene (TPB)
 - Other film WLS
 - **Xe-dopant** (λ = 175 nm)

 - Mixture stability?

LAr test chamber: gas system

LAr test chamber

PSD_{low}

X

X

PSD_{high}

+(?)

+(?)

X

IR

X

X

X

X





1 – vacuum vessel, 2 – PMT, 3 – copper housing, 4 – LAr volume, 5 – LN₂ bath, 6 – heater & termocontrol, 7 – gas filter Mycrolys, 8 – magnetoelectrical pump Nord & RGA, 9 – Ar (purity 99,9995%), 10 – cryogenic pump; B1– B3 – vacuummeters; M1 – M3 – manometers; V1– V15 – valve.

PSD plots and averaged WF with increasing of Xe concentration



At the concentration of 60 ppm (by mol) Xe in LAr one can see the beginning of the process of fast component reemission by Xe.

Averaged WF analysis



PSD quality and mixture stability

PSD quality $Q_{PSD}(\%) =$ part of α -particles obtained after cut by F40-parameter, ybackground reduced by factor of 1000.

35 2

	Test chamber configuration	Xe, ppm	Q _{PSD} %
	Black walls; no samples (Direct light registration)	1±1	99.9 ± 0.4
	Black walls, TPB	1±1	87.3 ± 0.7
	Black walls, TPB	30 ± 5*	87.2 ± 0.9
	Teflon walls, TPB	1±1	60 ± 2
	Teflon walls, FS	110 ± 32	100.0 ± 0.3
2.0	(*) Up to 30 ppm Xe Q _{PSD} is lower then for pure LAr with TPB. It is consistent with previous experiments [2-4].		

Wahl (gamma)

This work (alpha)

This work (alpha, T_{df})



Lower P, T at the beginning of long run => PMT parameters may vary. F40, T_f, T_s don't depend on PMT parameters. Mixture is stable.

1000

Averaged WF time parameters



 $I = A_f e^{-\frac{t}{T_f}} + A_s e^{-\frac{t}{T_s}} - A_d e^{-\frac{t}{T_d}}$ T_{fr} T_s – decay times for the fast and slow component correspondently, T_d – transfer time (the same parameter for the fast and slow component according C.G. Wahl et al)

- According to A. Hitachi [5]:
 - Transferring constant for the fast component in 3 times larger then for the slow component
 - Transfer mechanism for the fast component start working at big concentrations of Xe (200 ppm by mass)
- In this case light emission function should consist of 4 terms:

 $I = A_{f}e^{-\frac{c}{T_{f}}} + A_{s}e^{-\frac{c}{T_{s}}} - A_{df}e^{-\frac{c}{T_{df}}} - A_{ds}e^{-\frac{c}{T_{ds}}}$ T_{df} , T_{ds} – transfer time for the fast and slow components correspondently





 $k_f = (4.5 \pm 2.9) \times 10^{-11} \text{ cm}^3 \text{c}^{-1}$

- Theoretical prediction (A. Hitachi [5]):
- $k_f = 3.3 \times 10^{-11} \text{ cm}^3 \text{c}^{-1}$

7 S L

Conclusion

- We confirmed experimentally for the first time that the fast component is reemitted by high concentration of Xe-dopant
- Mixture stability was shown
- First experimental measurement of the transfer constant $k_{\rm f}$ was done
- PSD quality was shown to be better then for the pure LAr with TPB WLS
- Thus Xe-dopant with concentration of 200 ppm by mol can be used as the only one WLS in LAr detector

References

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